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03500.011969.36

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

NOBUMASA SUZUKI

Application No.: 09/657,971

Filed: September 8, 2000

For: MICROWAVE PLASMA
PROCESSING APPARATUS
AND METHOD THEREFOR

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Examiner: Luz L. Alejandro
Group Art Unit: 1703
June 2, 2004

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

EXPRESS ABANDONMENT UNDER 37 C.F.R. §1.138
AND RETURN OF ORIGINAL GRANT OF LETTERS PATENT

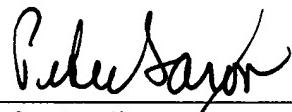
Sir:

In accordance with Title 37 C.F.R. §1.138, the undersigned who is authorized under 37 C.F.R. §1.33(b)(1) expressly abandons the subject reissue Application No. 09/657,971, filed September 9, 2000, but not the invention disclosed therein.

Further, it is requested that the original grant of Letters Patent No. 5,803,975 which was surrendered in a surrender paper filed December 11, 2002 herein, be returned to the undersigned.

Applicant's undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our below listed address.

Respectfully submitted,



Attorney for Applicant

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